



Attorney's Docket No.: 4936 USA Y1/ETCH/METAL/JB1

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)
)
Steven Verhaverbeke et al.)
)
U.S. Serial No: 09/945,454)
)
Filed: August 31, 2001)
)
For: A METHOD AND APPARATUS)
 FOR PROCESSING A WAFER)

Examiner: Moore, Karla A.
Art Unit: 1763

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Final Office Action mailed October 19, 2004 and the Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 filed concurrently herewith. Applicant respectfully requests the Examiner to enter this Amendment and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP _____
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